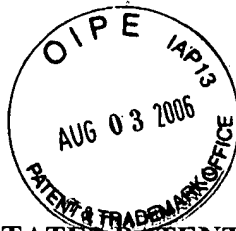


Docket No.: 060188-0782



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Toyoji ITO	:	Confirmation Number: 3918
	:	
Application No.: 10/786,070	:	Group Art Unit: 2823
	:	
Filed: February 26, 2004	:	Examiner: PARKER, John M.
	:	
For: METHOD FOR FABRICATION SEMICONDUCTOR DEVICE	:	

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 3, 2006, having a three-month shortened statutory period for response set to expire on July 3, 2006, and a one-month extension of time up to and including August 3, 2006 being filed concurrently herewith, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.